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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
09/608,302	06/30/2000	Gregory Michael Wilson	MEMC-98-4650(2293)	9819
321	7590 06/23/2003	•		
SENNIGER POWERS LEAVITT AND ROEDEL			EXAMINER	
16TH FLOO			KUNEMUND, ROBERT M	
ST LOUIS, N	40 63102		ART UNIT	PAPER NUMBER
			1765	1h
			DATE MAILED: 06/23/2003	wO

Please find below and/or attached an Office communication concerning this application or proceeding.

		<u> </u>			
	Application No.	Applicant(s)			
	09/608,302	WILSON ET AL.			
Offic Action Summary	Examiner	Art Unit			
	Robert M Kunemund	1765			
The MAILING DATE of this communication app Period for Reply	ears on the cover sheet with the C	orrespondence address			
A SHORTENED STATUTORY PERIOD FOR REPLY THE MAILING DATE OF THIS COMMUNICATION.  - Extensions of time may be available under the provisions of 37 CFR 1.13 after SIX (6) MONTHS from the mailing date of this communication.  - If the period for reply specified above is less than thirty (30) days, a reply of If NO period for reply is specified above, the maximum statutory period where the period for reply within the set or extended period for reply will, by statute, any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).  Status	36(a). In no event, however, may a reply be tim  y within the statutory minimum of thirty (30) day  vill apply and will expire SIX (6) MONTHS from  , cause the application to become ABANDONE	nely filed s will be considered timely. the mailing date of this communication. D (35 U.S.C. § 133).			
1) Responsive to communication(s) filed on 21 A	<u> April 2003</u> .				
2a) ☐ This action is <b>FINAL</b> . 2b) ☑ Th	is action is non-final.				
3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.					
Disposition of Claims					
4) Claim(s) 1-17 is/are pending in the application.					
4a) Of the above claim(s) is/are withdrawn from consideration.					
5) Claim(s) is/are allowed.					
6)⊠ Claim(s) <u>1-17</u> is/are rejected.					
7) Claim(s) is/are objected to.					
8) Claim(s) are subject to restriction and/o Application Papers	r election requirement.				
9) The specification is objected to by the Examine	r				
10) ☐ The drawing(s) filed on is/are: a) ☐ accepted or b) ☐ objected to by the Examiner.					
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).					
11) The proposed drawing correction filed on is: a) approved b) disapproved by the Examiner.					
If approved, corrected drawings are required in reply to this Office action.					
12) The oath or declaration is objected to by the Examiner.					
Priority under 35 U.S.C. §§ 119 and 120					
13) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).					
a) ☐ All b) ☐ Some * c) ☐ None of:					
1. Certified copies of the priority document	s have been received.				
2. Certified copies of the priority documents have been received in Application No					
3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).					
* See the attached detailed Office action for a list of the certified copies not received.  14) Acknowledgment is made of a claim for domestic priority under 35 U.S.C. § 119(e) (to a provisional application).					
a) The translation of the foreign language provisional application has been received.					
15) Acknowledgment is made of a claim for domestic priority under 35 U.S.C. §§ 120 and/or 121.					
Attachment(s)					
<ol> <li>Notice of References Cited (PTO-892)</li> <li>Notice of Draftsperson's Patent Drawing Review (PTO-948)</li> <li>Information Disclosure Statement(s) (PTO-1449) Paper No(s)</li> </ol>	5) Notice of Informal	y (PTO-413) Paper No(s) Patent Application (PTO-152)			

U.S. Patent and Trademark Office PTO-326 (Rev. 04-01) Application/Control Number: 09/608,302

Art Unit: 1765

## **DETAILED ACTION**

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

This application currently names joint inventors. In considering patentability of the claims under 35 U.S.C. 103(a), the examiner presumes that the subject matter of the various claims was commonly owned at the time any inventions covered therein were made absent any evidence to the contrary. Applicant is advised of the obligation under 37 CFR 1.56 to point out the inventor and invention dates of each claim that was not commonly owned at the time a later invention was made in order for the examiner to consider the applicability of 35 U.S.C. 103(c) and potential 35 U.S.C. 102(e), (f) or (g) prior art under 35 U.S.C. 103(a).

Claims 1 to 15 are rejected under 35 U.S.C. 103(a) as being unpatentable over Falster (PCT 38675) et al or Huber et al both in view of Aswad (Wo 99/03138)

The Falster et al and Huber et al references teach a method and apparatus for denuding a silicon wafer. A silicon wafer is placed in a heating chamber and heated to temperatures above 1175° c. The wafer is then cooled to temperatures below 800 °c at cooling rates, which can vary and are 10°c/sec or higher, note Falster pages 14-15, Huber et al entire reference. The sole difference between the instant claims and the prior art is the removal of the heated wafer to another chamber. However, the Aswad reference teaches moving heated wafer from one chamber to another via a Bernoulli wand, note entire reference. It would have been obvious to one of ordinary skill in the art to modify the Falster et al and Huber et al references by the

Application/Control Number: 09/608,302

Art Unit: 1765

teachings of the Goodwin et al reference to transfer the heated wafer in order to place the wafer in a cooling only chamber increasing control over the wafer.

Claims 16 and 17 are rejected under 35 U.S.C. 103(a) as being unpatentable over Falster (PCT 38675) et al or Huber et al both in view of Aswad.

The Falster et al, Huber et al and Aswad references are relied on for the same reasons as stated, supra, and differ from the instant claims in the heat source. However, in the absence of unobvious results, it would have been obvious to one of ordinary skill in the art to determine through routine experimentations the optimum, operable heating means in the Falster et al and Huber et al references in order to uniformly heat the wafer creating uniform properties.

## Response to Applicants' Arguments

Applicant's arguments filed April 24, 2003 have been fully considered but they are not persuasive.

Applicants' argument concerning where the cooling is done is noted. However, the specification indicates that the reaction chamber is a large chamber, which includes different areas, note figure. The Aswad reference teaches a chamber where the substrate is heated and move to another section for cooling, note figures. Thus, no difference is seen between the instant claims and the prior art.

The examiner has approved applicant's changes to the figures.

Application/Control Number: 09/608,302

Art Unit: 1765

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Robert M Kunemund whose telephone number is 703-308-1091. The examiner can normally be reached on 8 hours.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Ben Utech can be reached on 703-308-3636. The fax phone numbers for the organization where this application or proceeding is assigned are 703-305-3599 for regular communications and 703-305-3599 for After Final communications.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is 703-308-0651.

RMK June 20, 2003

ROBERT KUNEMUND PRIMARY EXAMINER